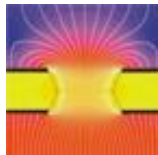


Towards MPGDs with embedded pixel ASICs

Lucian Scharenberg *on behalf of the CERN EP-DT-DD GDD team*

8th International Conference on Micro-Pattern Gaseous Detectors, USTC
14 October 2024



Outline

Motivation:

Why high-granularity readout of MPGDs? Why Timepix4?

1. Embedding into the amplification stage:

Simple PCB manufacturing techniques and intrinsic discharge protection.

2. First steps, triple-GEM:

Before embedding, explore GEMPix with Timepix4. Testing of TSV-Timepix4.

3. Large-area ASICs:

Long-term perspective and ideas for ambiguity-free readout

Summary



Motivation

High-granularity readout of gaseous detectors

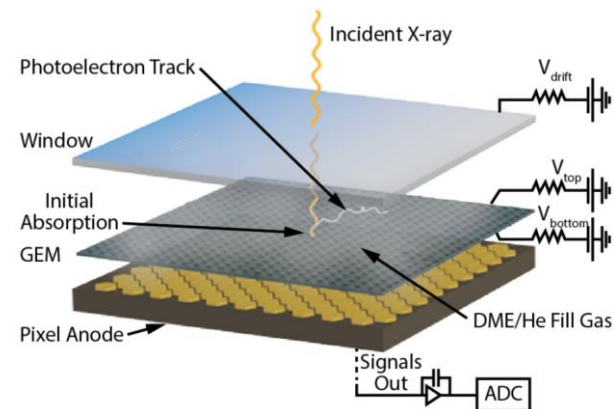
Possibilities offered by high-granularity readout of gaseous detectors:

- Low-material budget tracking with high spatial accuracy
- Event-selection based on geometrical signature
- Sensitivity to low-energetic photon interactions ($E_{\text{gamma}} < 2 \text{ keV}$)

Example applications:

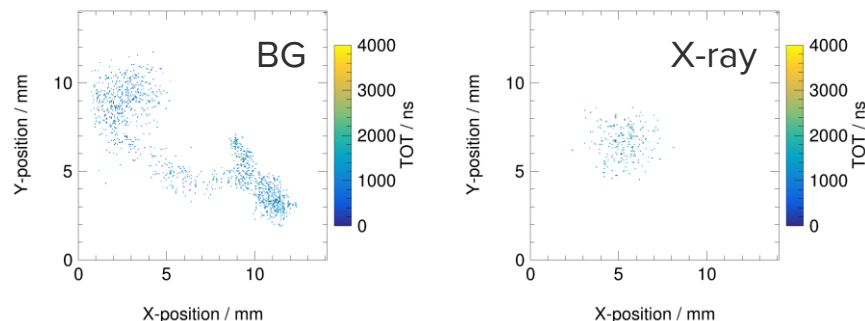
- X-ray polarimetry (e.g. IXPE @ NASA)
- Nuclear recoil events (e.g. MIGDAL, CYGNO)
- Material science (e.g. MIXE @ PSI)
- Axion helioscopes (e.g. IAXO)
- Micro dosimetry (e.g. GEMPix)

Illustration for X-ray polarimetry @ IXPE



https://ixpe.msfc.nasa.gov/for_scientists/papers/2017spie_0829_sgro.pdf

Geometry selection with GridPix data



Hybrid pixel ASICs

The Timepix4

Most commonly used ASIC for this purpose: **Timepix family**

→ Use **bump-bond pads** for semiconductor sensor **as charge collection pads**

Timepix4: latest version of the Timepix

→ $2.5 \times 3.0 \approx 7 \text{ cm}^2$ active area with **448 x 512 pixels** (55 μm square pitch)

→ **700 electrons energy resolution**

→ Up to **60 ps front-end time resolution**

→ Up to **3 MHz/mm² hit rate (data-driven)** and up to 5 GHz/mm² (frame-based)

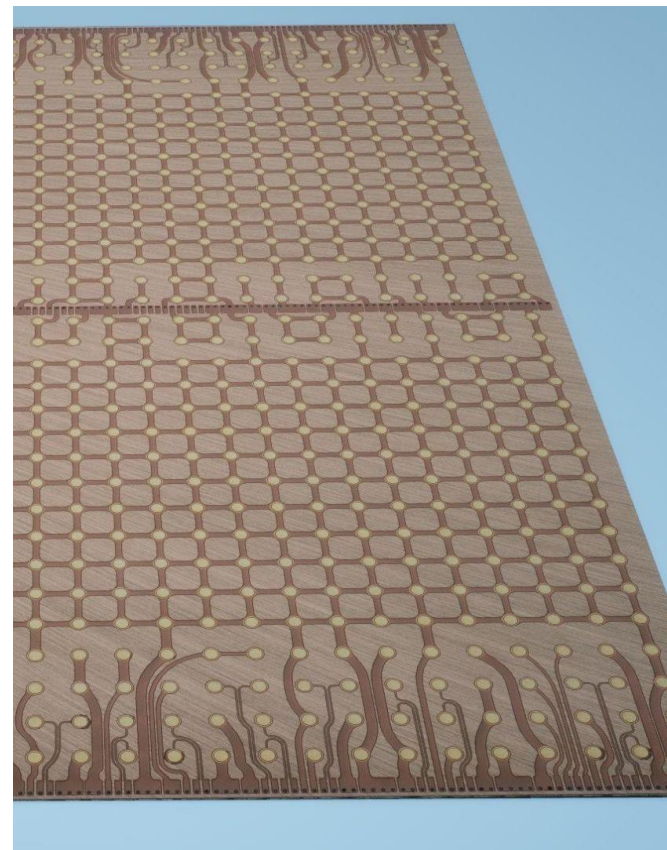
Most interesting feature for us: 4-side tileable

→ Connect from the back-side, using **Through Silicon Vias (TSVs)** with Redistribution Layer (RDL)

→ No dead area, **no wire bonds!** Required for embedding process

Backside of a TSV-Timepix4

Courtesy of Jerome Alozy



Part 1: embedding concept and status

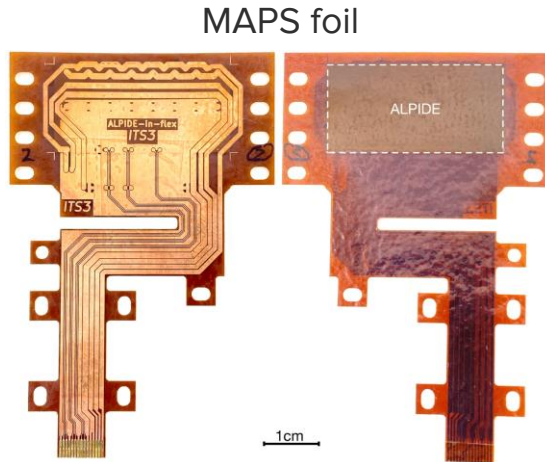
Embedding approach

New research line with CERN EP R&D Work Package 2

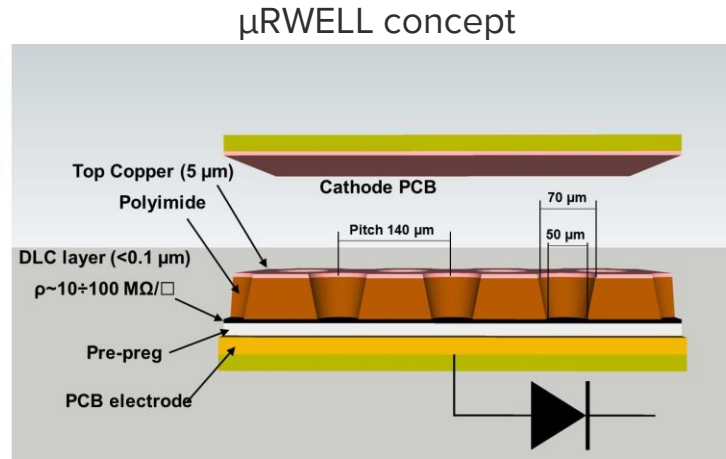
Embedding of front-end ASICs in flexible PCB, i.e. micro-pattern amplification structures

→ Possible with **Micro-Resistive Well (μ RWELL)** structure, **using standard PCB technologies**

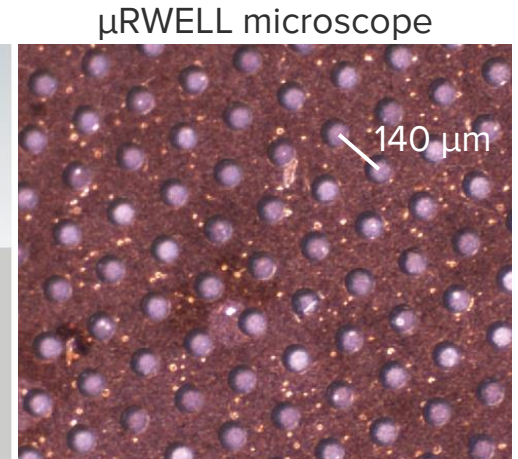
→ Conceptually inspired by “**MAPS foil**” (Magnus Mager and Rui de Oliveira): [MPGD 2022](#)



<https://doi.org/10.1016/j.nima.2022.167673>



<https://doi.org/10.1088/1748-0221/14/05/P05014>



<http://doi.org/10.1088/1748-0221/10/02/P02008>

Embedding approach

New research line with CERN EP R&D Work Package 2

Embedding of front-end ASICs in flexible PCB, i.e. micro-pattern amplification structures

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- Conceptually inspired by “**MAPS foil**” (Magnus Mager and Rui de Oliveira): [MPGD 2022](#)
- Embedding **only possible, because of TSVs** (wire bonds and pads interfere laminating procedure)



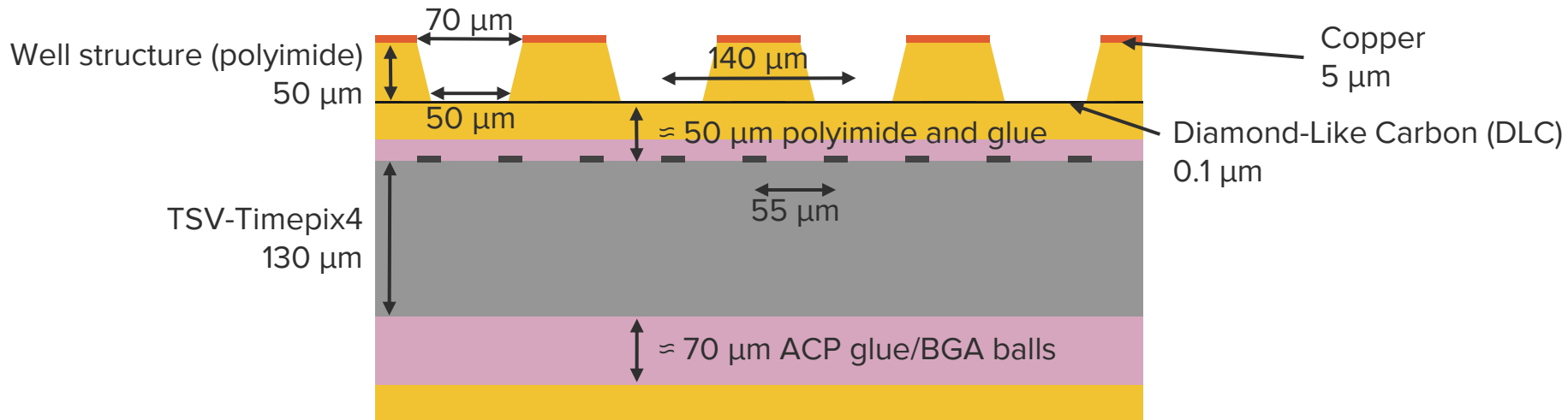
Not drawn to scale!

Embedding approach

New research line with CERN EP R&D Work Package 2

Embedding of front-end ASICs in flexible PCB, i.e. micro-pattern amplification structures

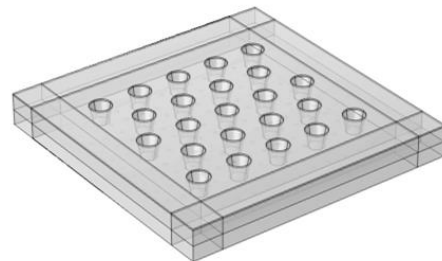
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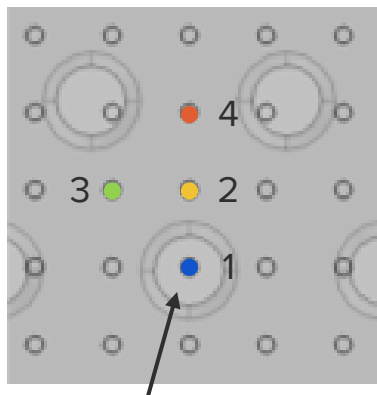
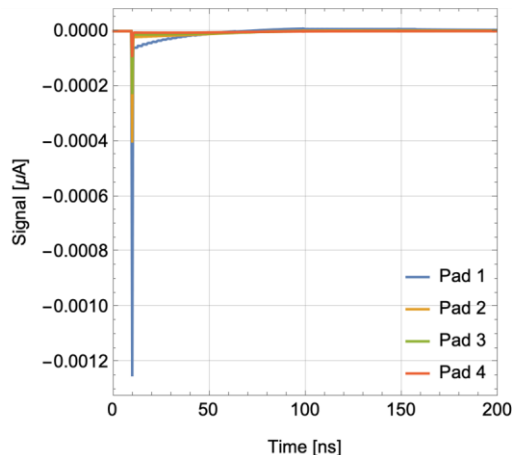
Signal induction simulation

How is the charge measurement affected?

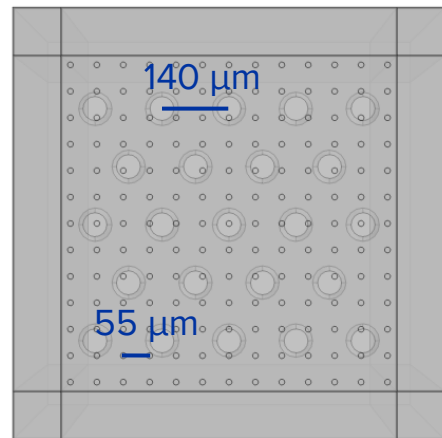
- Distance (up to 50 μm) between DLC and charge collection pads
- Different geometry between Timepix4 pixels and μRWELL holes



Simulation of signal induction using **COMSOL** and **Garfield++** (Djunes Janssens)



Avalanche in single hole



Next step: include front-end response, i.e. Timepix4 transfer function

Next steps and production status

Designed and produced custom detector PCB (William Billereau)

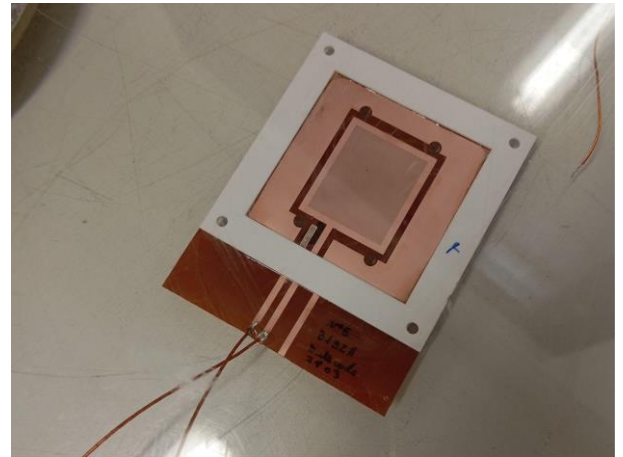
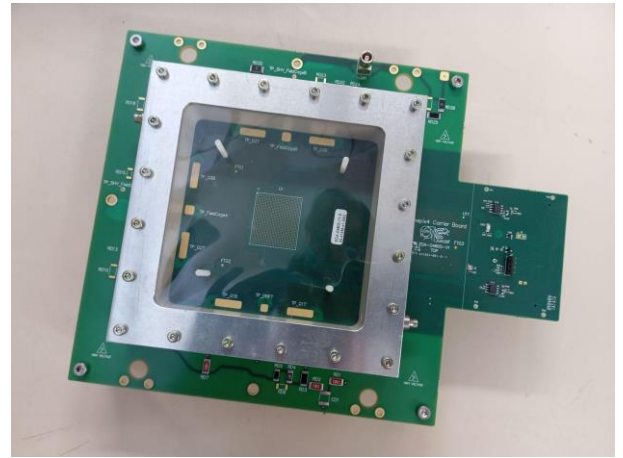
- Based on Nikhef carrier
- Support typical MPGD R&D detector housing

Allows **μ RWELL test without embedding** and various GEM configurations

- Electrostatic coupling between μ RWELL foil and TSV-Timepix4
- After low yield in first production, **new production ongoing**

Received electrically broken TSV-Timepix4v0

- At CERN MPT workshop for **mechanical tests of embedding**



Part 2: performance evaluation with GEM

Well-known technology (GEMPix) to understand gaseous detector properties and software optimisation

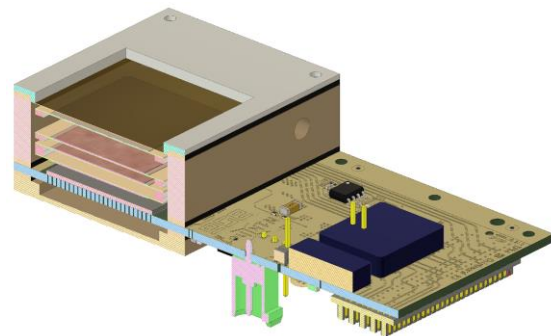
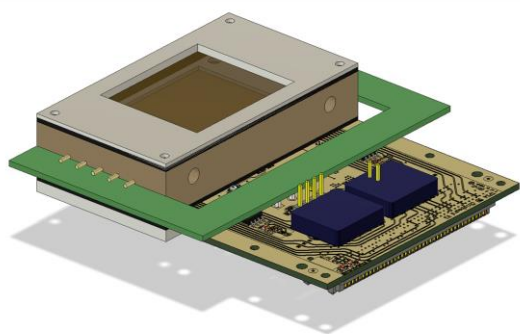
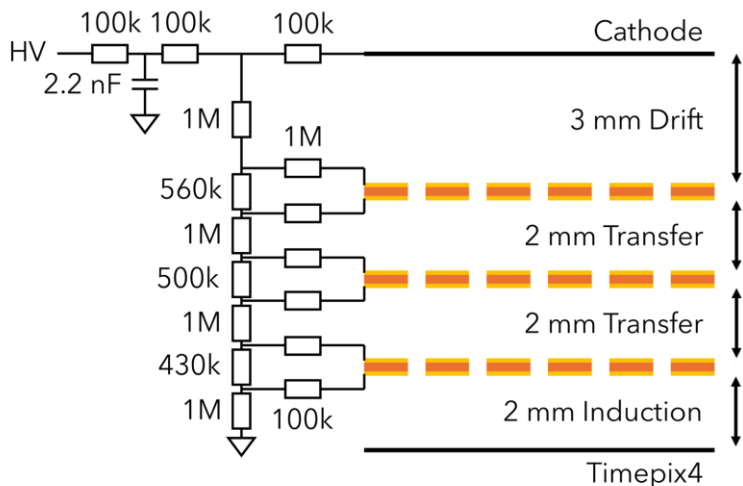
Triple-GEM detector for TSV-Timepix4v1

Detector design

Small gas volume with **3 mm drift/interaction region**, filled with **Ar/CO₂ (70/30)**

→ **Triple-GEM** well established with Timepix (GEMPix)

→ **Reach sufficient gain while maintaining low discharge probability** (bare, unprotected Timepix)

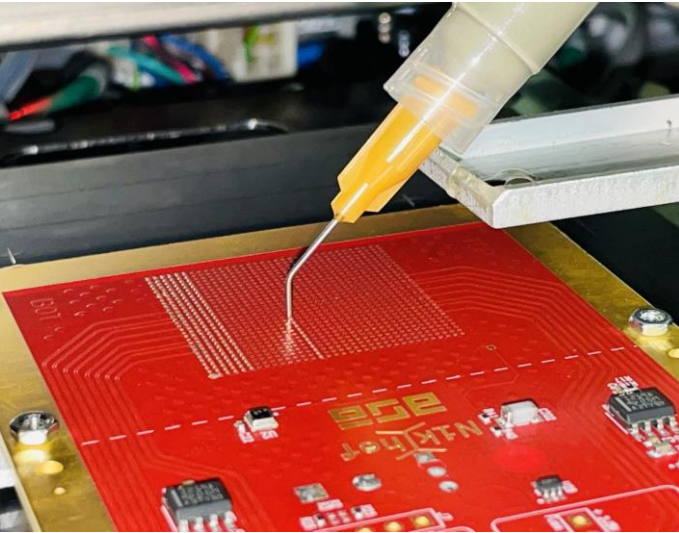


Fit on **default carrier board** of reference readout system:
SPIDR4 from Nikhef

Triple-GEM detector for TSV-Timepix4v1

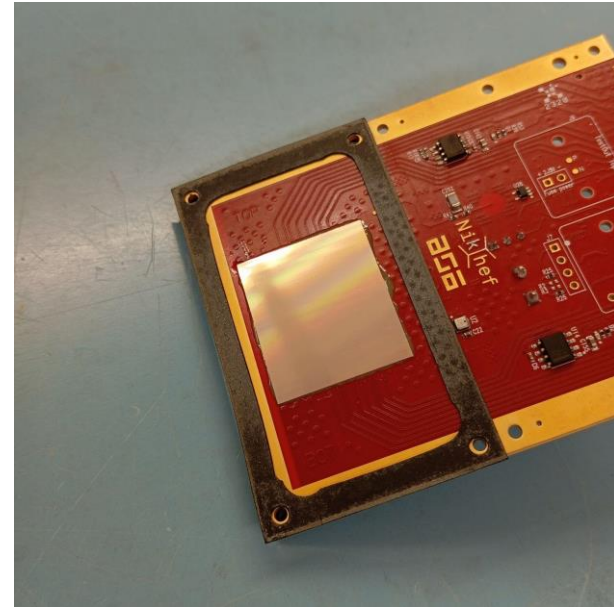
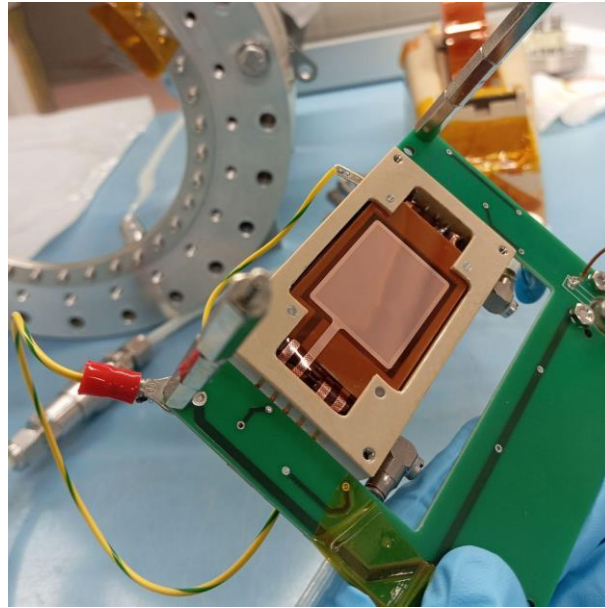
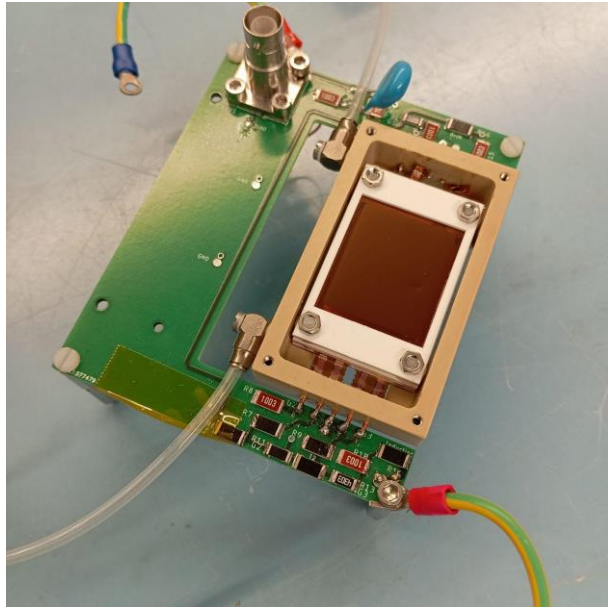
Assembly of TSV chips

Chip assembly through **ACP** (Anisotropic Conductive Paste) on Nikhef carrier at University of Geneva
(Mateus Vicente):



Triple-GEM detector for TSV-Timepix4v1

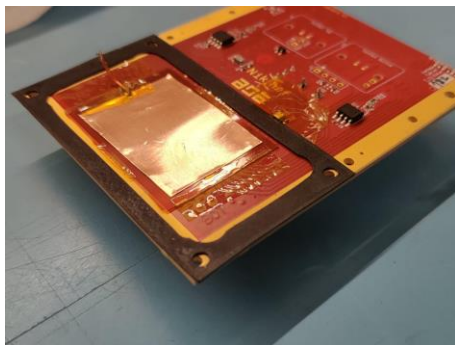
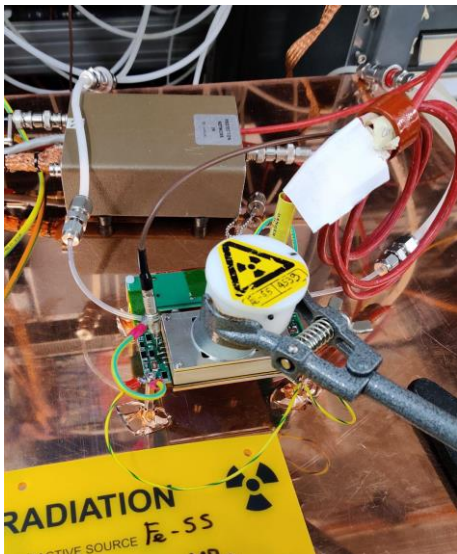
Detector assembly (GEMPix4)



Detector with $2.5 \times 3.0 \text{ cm}^2$ active area surprisingly complicated in handling and operation.

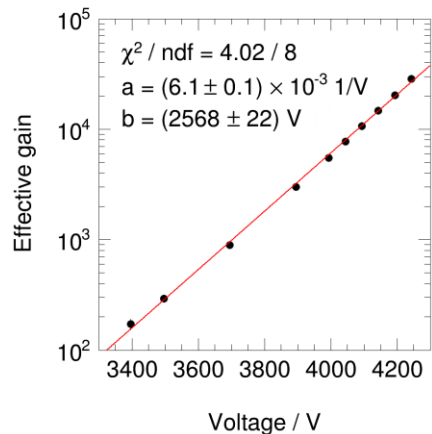
Triple-GEM detector for TSV-Timepix4v1

Single-channel characterisation

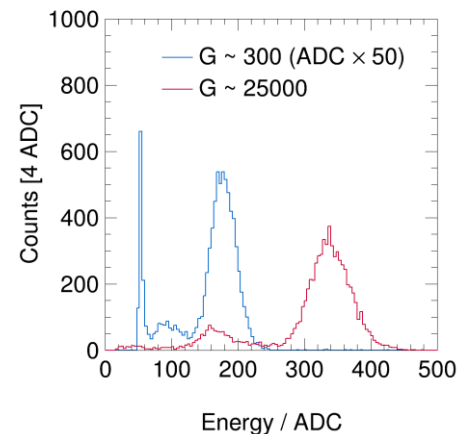


Single-channel copper electrode, read out with NIM electronics (pre-amp, shaper, MCA + picoammeter for anode current)

Gain curve



^{55}Fe spectra at different gains



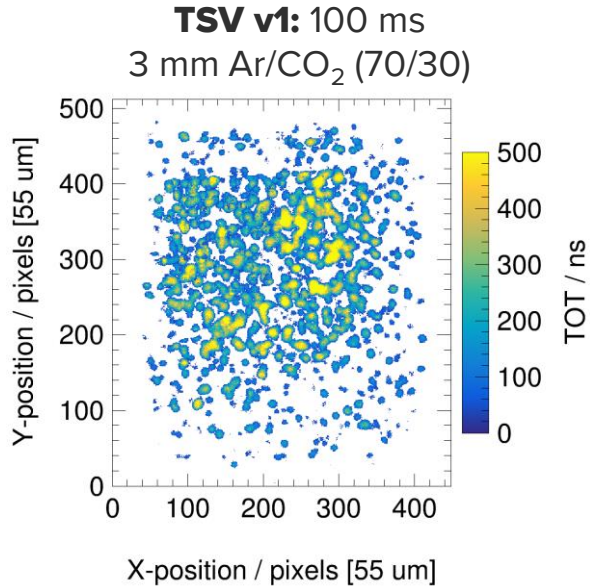
→ Gains > 25k without discharges

→ Good energy resolution at low gains

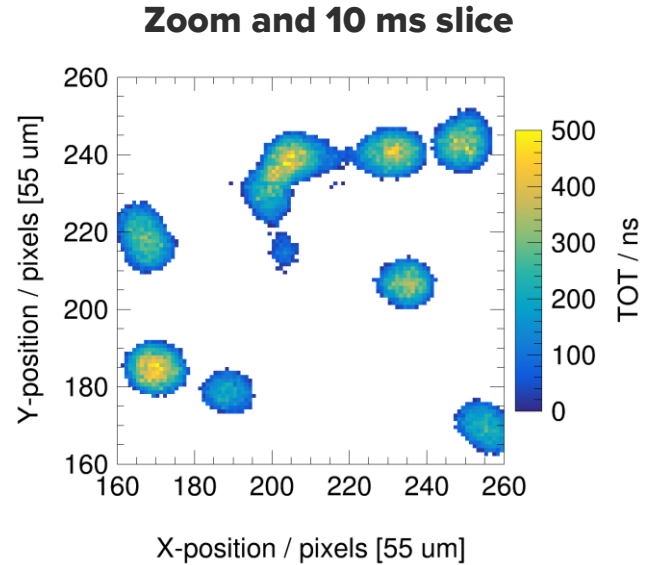
First results

Individual interactions

Measurements with ^{90}Sr at $G \approx 5000$



3 mm drift is too thin for full absorption

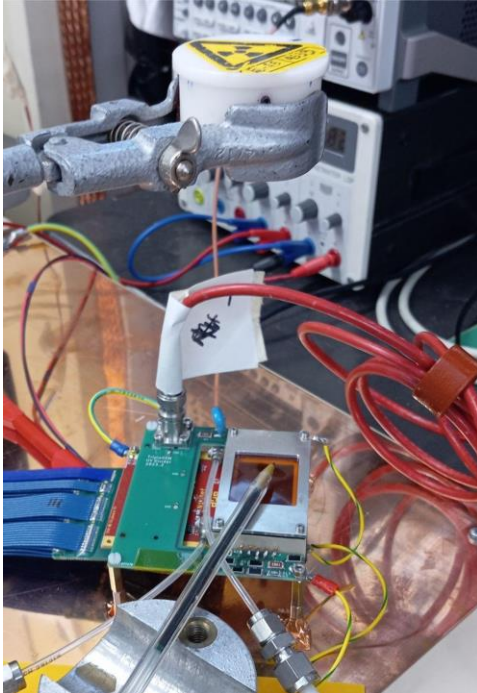


$\approx 10^2$ pixels per interaction

First results

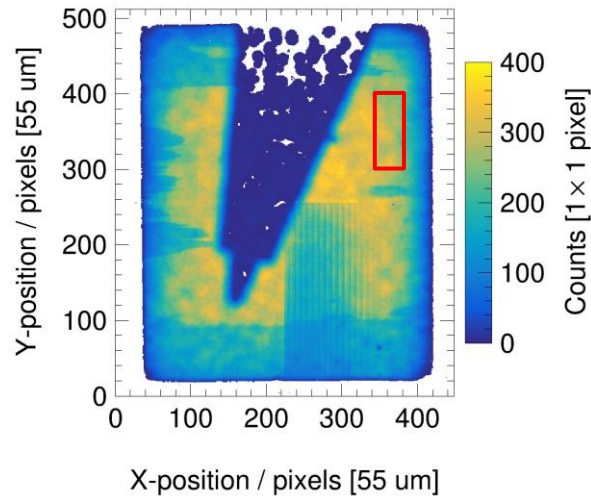
Imaging

First X-ray image recorded with TSV-Timepix4



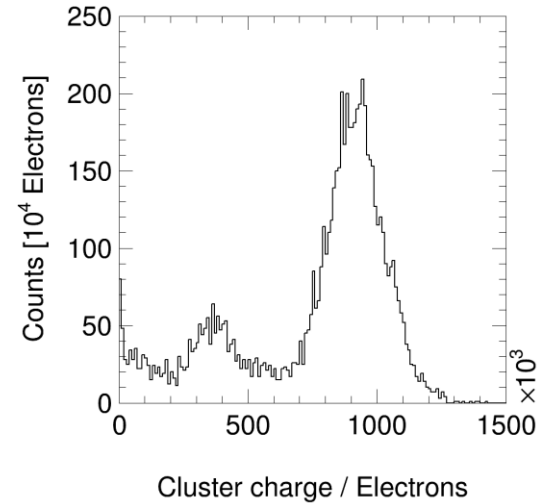
Hits only

Image of pen, low interaction rate
2000 s acquisition time



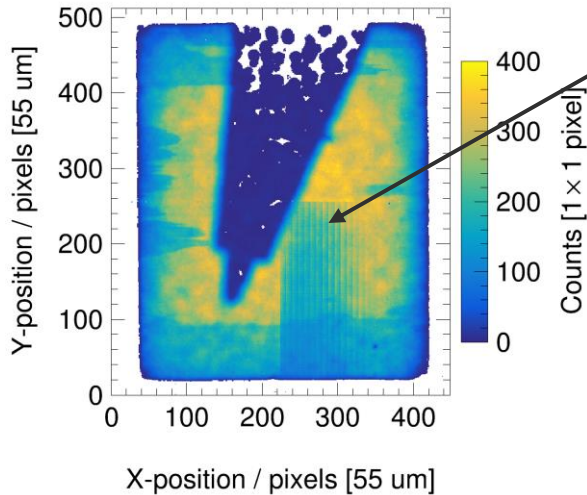
Clusters

Rudimentary clustering
Only within selected region



Detector gain \leq 5000

Next steps with GEMPix4



Redo measurements with **Timepix4v2** (Fast-links work correctly)
→ 10 Gbps instead of 40 Mbps over slow control links

Flat-field corrected image and understanding of origin of image features

Explore the possibility of a **2 x 2 chip matrix and larger area** readout

Continue the work of Fabrizio Murtas with his colleagues from the **CERN RP Dosimetry team** (Pierre Carbonez, Tristan Genetay and Andrea Garcia-Tejedor)

→ Optimisation of the detector

→ Applications (e.g. micro dosimetry or part of CT in hospitals)

Part 3: future perspective and dreams

Other front-end ASICs and readout boards in silicon

Large area coverage

Typical gaseous detector applications

Pixel/pad readout = **ambiguity free**

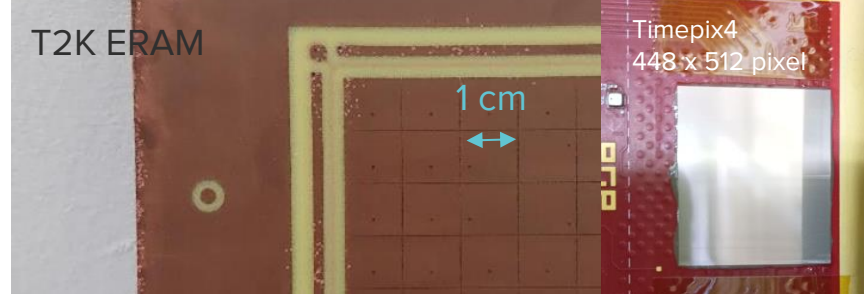
Examples of pad readout:

- ALICE Time Projection Chamber: $4 \times 7 \text{ mm}^2$, $6 \times 10 \text{ mm}^2$, $6 \times 12 \text{ mm}^2$ and $6 \times 15 \text{ mm}^2$
- T2K Time Projection Chambers: $10 \times 11 \text{ mm}^2$
- RHUM project: $1 \times 3 \text{ mm}^2$, $1 \times 8 \text{ mm}^2$ and $10 \times 10 \text{ mm}^2$
- MPGD-based DHCAL: $10 \times 10 \text{ mm}^2$
- Picosec MicroMegas: $10 \times 10 \text{ mm}^2$

Compare with typical pixel ASICs: $0.055 \times 0.055 \text{ mm}^2$

Large area gaseous detector applications do not require this fine granularity

→ Find a solution with e.g. **$1 \times 1 \text{ mm}^2$ or $3 \times 3 \text{ mm}^2$ pads**



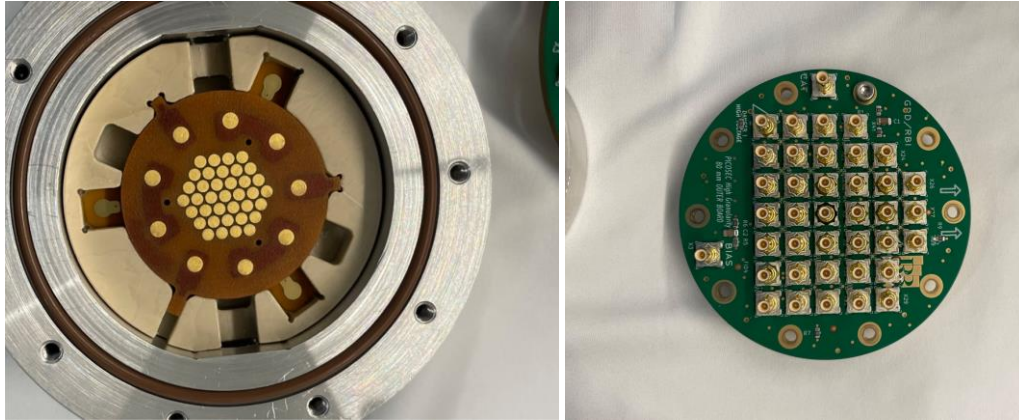
<https://indico.cern.ch/event/973503/contributions/4099220/>

Other front-end ASICs

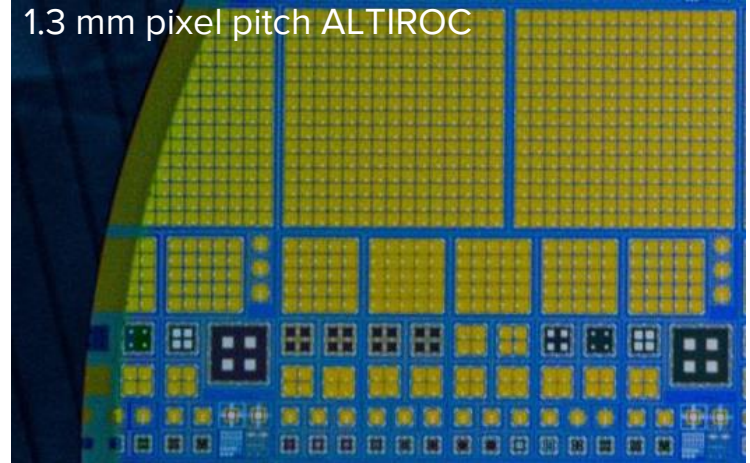
Establish a manufacturing technique that can be applied to other ASICs

- Use ASICs with larger pixel pitch, e.g. **ALTIROC** or **ETROC** (both 1.3 mm pitch)
- Could enable **high-granularity Picosec** MicroMegas/ μ RWELL with **integrated front-end electronics**

High-granularity Picosec MM (2 mm pads, discrete electronics)



Courtesy of Florian Brunbauer



<https://indico.cern.ch/event/1323113/contributions/5823798/>

Dreaming a bit – the silicon readout board

General idea

Go beyond the “classical” front-end ASIC

- Timepix4 and ALTIROC <math> < 10 \text{ cm}^2 </math>
- Gaseous detectors > 100 cm²

Go beyond the “classical” PCB

- PCB with 30 x 30 pads of 3 x 3 mm² size very expensive (several kCHF)
- Does not include front-end electronics (900 channels = e.g. 8 VMM3a hybrids = several kCHF on top)

Typical wafer costs (does not include the mask): 1 to 4 kCHF

- **Why not make a readout board from a wafer?**

The silicon readout board for gaseous detectors!



300 mm Timepix4 wafer (diced)

<https://indico.cern.ch/event/1413681/contributions/5998158/>

Dreaming a bit – the silicon readout board

Advantages

Why not make a readout board from a wafer?

The silicon readout board for gaseous detectors!

Example: $100 \times 100 \text{ mm}^2$ ASIC with $3 \times 3 \text{ mm}^2$ pixels

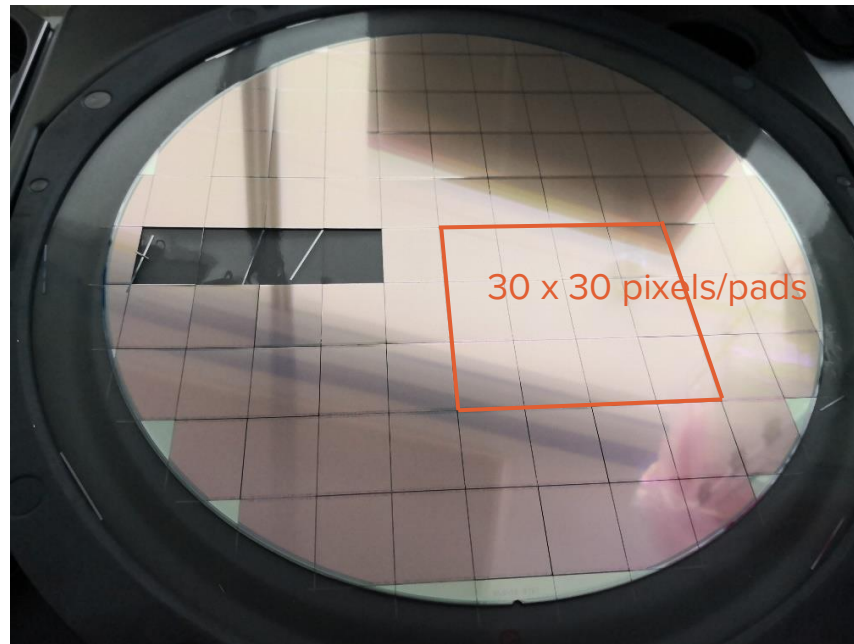
→ Ambiguity free, large-area readout

Cheap process possible (e.g. 130 nm instead of 28 nm)

With $3 \times 3 \text{ mm}^2$ pads

→ Sufficient space for redundancy and discharge protection

→ Increase reliability of electronics



Summary and next steps

Summary and next steps

New research line on **embedding of high-granularity readout ASICs in micro-pattern amplification stage**

→ Profit from the capabilities of **TSV-Timepix4**

→ **First promising results obtained with GEMPix4**, allows to study signal induction and electronics understanding and optimisation

Next steps with Timepix4

→ Perform **tests with μ RWELL**, first without embedding

→ Mechanical embedding tests at CERN MPT workshop

→ Target construction of **multi-chip PCB** with e.g. 2 x 2 chip matrix

Future goals and dreams

→ Test different front-end ASICs, e.g. **ALTIROC** or **ETROC**

→ Start development of **silicon readout board**

Acknowledgements

**This project is only possible, because of the help and support from many people.
Many thanks to all of them!**

CERN:

Jerome Alozy, William Billereau, Florian Brunbauer, Michael Campbell, Pierre Carbonez, Tristan Genetay, Djunes Janssens, Xavi Llopart, Magnus Mager, Rui de Oliveira, Eraldo Oliveri, Francisco Piernas Diaz, Miranda van Stenis

University of Geneva:

Mateus Vicente

Nikhef:

Martin Fransen, Kevin Heijhoff, Martin van Beuzekom, Bas van der Heijden



Thanks for your attention :-)



Lucian.Scharenberg@cern.ch

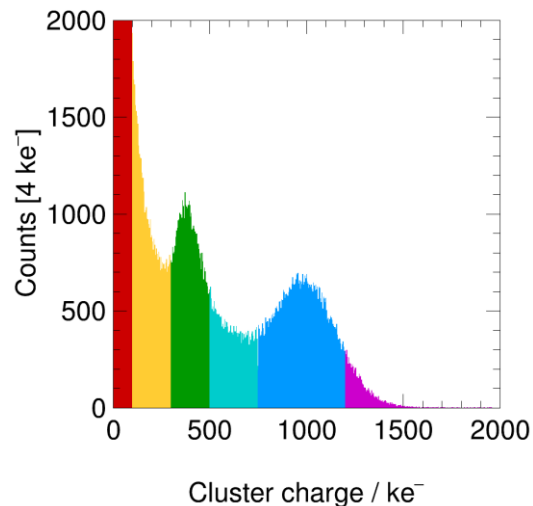
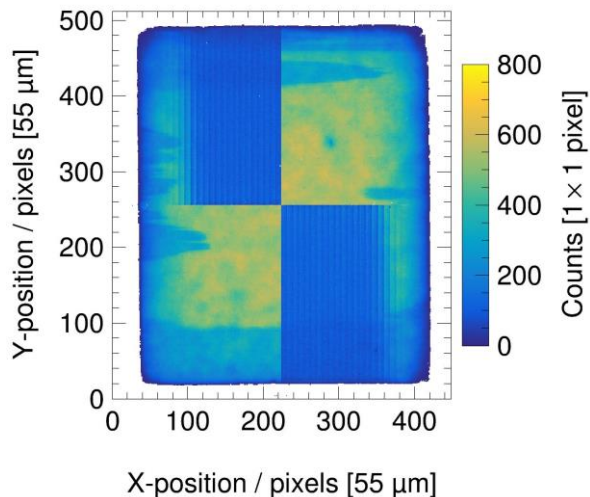
Back-up slides

First results

Spectroscopy

X-ray **image has some structures**. Affects the quality of the ^{55}Fe spectrum.

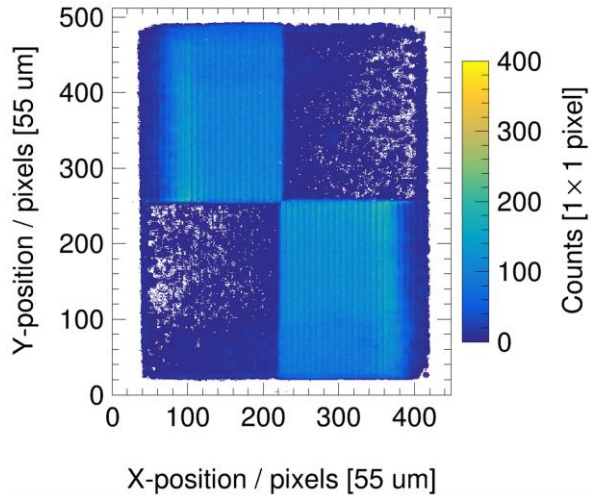
Use the cluster information to **select the energy** and the plot the **hit positions** for each energy slice.



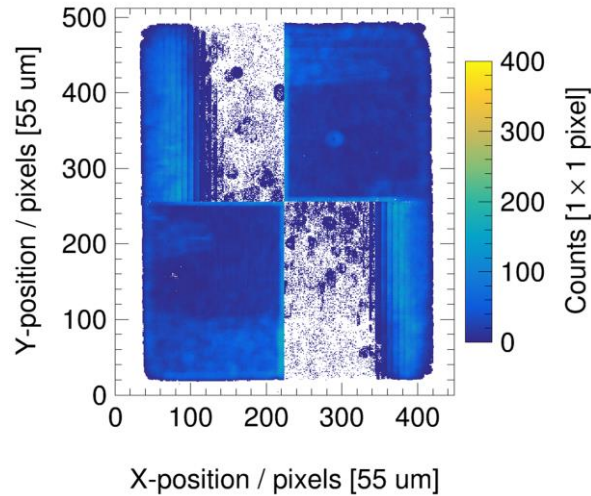
First results

Spectroscopy

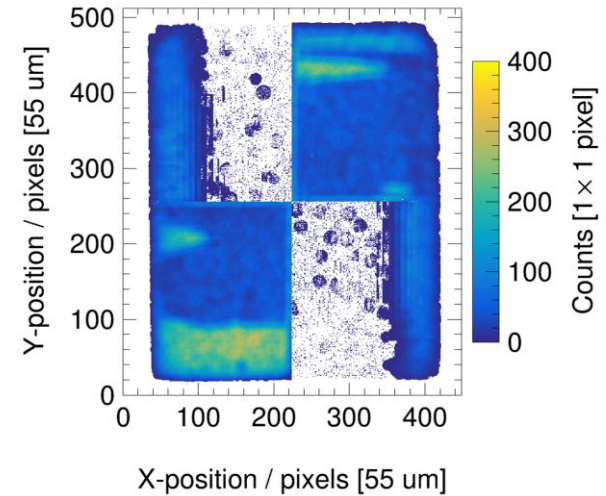
Use the cluster information to select the energy and the plot the hit positions for each energy slice.



0 to 100 ke



100 to 300 ke



300 to 500 ke

First results

Spectroscopy

Use the cluster information to select the energy and the plot the hit positions for each energy slice.

